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Notice of Allowability	Application No.	Applicant(s)	Applicant(s)	
	10/767,786	OHTO ET AL.		
	Examiner	Art Unit		
	Ori Nadav	2811		
The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in or other appropriate communication. This application is su	this application. If not include nication will be mailed in due	ed course THIS	
1. A This communication is responsive to <u>amedment filed on 5/4</u>	<u>8/2006</u> .			
2. X The allowed claim(s) is/are 1-26 and 83-89.				
 Acknowledgment is made of a claim for foreign priority un a) All b) Some* c) None of the: Certified copies of the priority documents have Certified copies of the priority documents have Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). 	been received. been received in Application	No	ion from the	
* Certified copies not received:				
Applicant has THREE MONTHS FROM THE "MAILING DATE" of noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file a ENT of this application.	a reply complying with the req	uirements	
 A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which give 	tted. Note the attached EXAMs reason(s) why the oath or o	MINER'S AMENDMENT or No declaration is deficient.	OTICE OF	
5. CORRECTED DRAWINGS (as "replacement sheets") must	t be submitted.			
(a) ☐ including changes required by the Notice of Draftsperso		(PTO-948) attached	•	
 hereto or 2) ☐ to Paper No./Mail Date 				
(b) including changes required by the attached Examiner's Paper No./Mail Date				
Identifying indicia such as the application number (see 37 CFR 1.6 each sheet. Replacement sheet(s) should be labeled as such in the	84(c)) should be written on the ne header according to 37 CFR	drawings in the front (not the 1.121(d).	back) of	
 DEPOSIT OF and/or INFORMATION about the depose attached Examiner's comment regarding REQUIREMENT F 	it of BIOLOGICAL MATER FOR THE DEPOSIT OF BIOL	RIAL must be submitted. N OGICAL MATERIAL.	ote the	
		,		
Attachment(s)				
1. Notice of References Cited (PTO-892)	5. Notice of Info	rmal Patent Application (PTO	-152)	
2. Notice of Draftperson's Patent Drawing Review (PTO-948)		6. ☐ Interview Summary (PTO-413), Paper No./Mail Date		
 Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date 		7. Examiner's Amendment/Comment		
Examiner's Comment Regarding Requirement for Deposit of Biological Material		8. Examiner's Statement of Reasons for Allowance		
	9. 🗌 Other	and		
		ORI NADAV PRIMARY EXAMINE	ER .	

DETAILED ACTION

Examiner's Amendment

This application is in condition for allowance except for the presence of claims 27-38 directed to a non-elected embodiment without traverse. Accordingly, claims 27-38 have been cancelled.

Please change the title from "semiconductor device, and production method for manufacturing such semiconductor device" to "semiconductor device having two distinct SiOCH layers". A new title was required, because the title of the invention was not clearly indicative of the invention to which the claims are directed.

Reasons for allowance

The following is an examiner's statement of reasons for allowance: The prior art of record does not teach or suggest, singularly or in combination, at least the limitations of a semiconductor device having a second SiOCH layer of a hydrogen density that is lower than that of a first SiOCH layer.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Application/Control Number: 10/767,786

Art Unit: 2811

Page 3

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Ori Nadav whose telephone number is 571-272-1660. The examiner can normally be reached between the hours of 7 AM to 4 PM (Eastern Standard Time) Monday through Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Eddie Lee can be reached on 571-272-1732. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

O.N. 7/4/06

ORI NADAV
PRIMARY EXAMINER
TECHNOLOGY CENTER 2800